

## Index

### a

absolute vacuum, 16  
 absorption, 232, 472, 473, 513, 535, 673, 674, 969  
 absorption method, 673, 925  
 accommodating time, 927, 928, 933  
 accommodation coefficient, 51, 58, 59, 175, 177, 589  
 – of tangential momentum, 728  
 activated carbon, 524  
 activation energy, 229, 230, 235, 247  
 adhesives, 792  
 adiabatic behavior, 96, 311, 342, 344  
 adparticles, 229, 232  
 adsorbate, 229, 231, 233, 245  
 adsorbents, 232, 466, 467, 471, 521, 526, 560  
 adsorption, 233, 235, 473  
 adsorption behavior, 494  
 adsorption energy, 229, 232, 243  
 adsorption flux density, 235  
 adsorption heat, 229, 467  
 adsorption kinetics, 234  
 adsorption phase, 232, 526  
 adsorption pump, 466, 470, 471, 894, 903  
 – design, 7  
 – operating suggestions, 331, 404, 471  
 – ultimate pressure, 262  
 – ultimate pressure with two or more, 469  
 – working principle, 314  
 adsorption rate, 234, 235, 242  
 air conditioner, 89, 936  
 airflow, 118, 119, 153, 367  
 air inflow, 104, 120  
 air leak, 924  
 air pump, 5  
 alkali ion sensor, 685, 691, 925  
 aluminum, 751  
 American Vacuum Society, 724, 726  
 ammonia, 67, 530, 925

Amontons, 7, 35  
 amount of substance, 34  
 analytics, 26, 304, 457, 459  
 aperture, 101, 102, 132, 136, 150, 152, 308, 677  
 Aristotle, 1  
 Arrhenius plot, 77  
 ASCII protocol, 846  
 ATEX, 348, 349  
 atom, 1, 12  
 atomic bonds, 229  
 atomic mass, 35, 685  
 – unit, 35, 946  
 attractive-soft-sphere model, 70  
 Avogadro's constant, 34, 35  
 axial ionizer, 650  
 axial ion source, 651

### b

back diffusion, 399, 400  
 backflow, 261, 265, 401  
 backing pressure, 26, 272  
 backing pump, 261  
 backpressure, 389  
 baffle, 534, 535, 541, 544  
 baffle plate, 402, 719  
 bake-out, 238, 479, 526, 835  
 baking, 240, 248  
 Baliani, 2  
 ball bearing, 304, 420, 421, 440, 444  
 base pressure, 450, 451, 456  
 bath cryopump, 541, 542  
 bath cryostat, 520, 521, 747  
 Bayard, 15, 609  
 Bayard-Alpert ionization gauge, 615  
 beaming effect, 148, 151  
 Beams, J. W., 14  
 Becker, W., 420  
 bellows, 304, 815  
 Bernoulli's equation, 95

- Berti, Gasparo, 2, 3  
 BET isotherm, 244, 245  
 BGK model equation for rarefied gas flow, 175  
 blade angle, 431, 434, 435  
 blade velocity, 430, 431  
 Blasius equation, 116  
 boiling point, 369, 373, 514, 748  
 Boltzmann, 438, 697  
 Boltzmann equation, 167, 170, 171  
 Boltzmann's constant, 697  
 bombing, 940  
 bonding, 784  
   – adhesive, 791  
 booster pump, 317, 682  
 Bourdon tube vacuum gauge, 569, 570  
 Boyle, 7, 9  
 Boyle Mariotte law, 35, 466  
 brazed joints, 24  
 brazing, 527, 578, 602, 783, 786, 787  
   – high-temperature  
 Brunauer, 244  
 Brunauer-Emmett-Teller isotherm, 244  
 Brunel, 10  
 bubble emission method, 922, 940  
 buckling, 812  
 bulk getters, 473, 474  
   – pump, 463, 464, 479, 893, 958  
 bulk velocity, 100, 168, 171, 180, 203, 708  
 bus system, 843  
 butane, 67, 685, 686  
 butterfly valve, 818
- C**
- calibration, 26, 32, 565, 580, 611, 644, 690, 700, 713, 720, 724, 729, 733, 737  
 calibration chamber, 718, 719, 721, 722, 731  
 calibration factor, 690  
 calibration gas, 713  
 calibration method, 723, 729, 734  
 calibration system, 26, 717, 721–725, 733, 736, 939  
 capacitance diaphragm gauge, 577–582, 699, 704, 719, 724–727, 871  
 capillary, 131, 605, 606, 689, 703, 705, 736, 934  
 capillary depression, 703, 705  
 capillary leak, 688, 734  
 capsule element vacuum gauge, 568, 569  
 capsule pump, 288  
 carbon dioxide, 19, 38, 67, 505, 526, 530, 545, 647, 912  
 carbon fiber sleeve, 426, 442  
 Carnot cycle, 513  
 Carnot efficiency, 513, 516  
 Carnot process, 513  
 cathode sputtering, 494, 499  
 cavitation, 500  
 cavitation limit, 280, 281  
 cavitation protection, 283  
 Celsius temperature, 31, 32  
 cemented joints, 917, 926  
 ceramics, 527, 748, 751, 757, 758, 770, 788, 824–826, 825, 872  
 CF flange, 801  
 chambers, 807  
   – double-walled, 808  
 change of state, 95, 96, 107, 311, 513  
 Chapman, 54, 72  
 Charles, 35  
 check valve, 291, 863  
 chemical diaphragm pump, 264, 266  
 chemical process, 395  
 chemisorption, 229, 230  
 chevron baffle, 402, 560, 859  
 Chun, 253  
 circular tube, 85, 115, 116  
   – conductance, 126  
   – flow, 116  
 CIS (closed ion source), 649, 651  
 Clausing, 9, 134, 138  
 Clausius-Clapeyron equation, 76, 77  
 claw pump, 313  
   – compression principle, 314  
   – exact profile, 313  
   – Northey type, 313  
   – speed control, 318  
 cleaning, 291, 293, 321, 371, 628, 732, 782  
 cleaning processes  
   – CERN, 781  
 clean room, 685, 782, 838, 839  
 clearance, 13, 142, 288, 303  
 CL scattering law, 183, 198, 208, 217, 218  
 coefficient of heat transmission, 366  
 COF components, 804  
 COF flange, 804  
 coiled-tube condenser, 369, 370  
 cold trap, 541, 679, –681, 705, 707, 879, 917, 932, 933  
 collision  
   – mean time between collisions, 49  
   – volume collision rate, 49, 50, 65, 944, 945  
 collision frequency, 40  
 collision integral, 73  
   – reduced, 73  
 collision rate, 44, 49  
 comparison method, 700, 723, 737

- compound pump, 422, 439, 440, 442, 451, 453, 455
  - turbomolecular, 681, 683, 684
- compression
  - adiabatic, 343
  - internal, 288, 309, 313, 315, 317
  - isentropic, 343
  - isothermal, 343
  - manometer, 704
  - polytropic, 311, 343
  - power, 344
- compression ratio, 222, 262, 323, 324, 330, 399, 425, 433, 451, 452, 492
  - diffusion pump, 451
  - effective, 324
- compression shock, oblique, 106
- compression work, 312, 335
- computer simulation, 42, 65, 139, 698
- condensate layer, growth rate, 551
- condensates, 538
- condensate, thermal conductivity, 537
- condensation, 523
  - flux density, 548
  - probability, 769
- condensation area, 369
- condensation flux density, 548
- condensation heat, 281, 361–363, 365, 380, 531
- condensation pump, 525, 721
- condensation temperature, 361, 367, 368, 396, 526, 528
- condenser, 361–382
  - condensate discharge, 370, 372, 374
  - coolant, 361, 362, 368, 371
  - direct contact, 372–374, 394, 395
  - surface, 370, 374, 393, 395
- conductance
  - aperture, 140, 154
  - assembly, measurement, 164
  - circular tube, 118, 126
  - flow, molecular, 135, 136
  - inherent, measurement, 162
  - intrinsic, 139, 146
  - intrinsic, measurement, 140, 162
  - long tube, circular cross section, 154
  - reduced, measurement, 162, 164
- conductance function, 154, 155
- conductance leak, 688
- conductivity
  - thermal, 39, 51, 55, 60, 72, 366, 520, 527, 537, 538, 594, 597, 599, 601, 603, 604
- connections
  - detachable, 793
- conservation laws, 93, 106
- conservation of energy, 95, 106
- conservation of mass, 94, 95, 106
- conservation of momentum, 94, 106
- contaminations, 780
- contraction, 101, 114, 152
- control rotor, 313, 315, 317
- coolant, 365
- cooling water, 312, 369, 371, 375, 394, 404
- copper
  - OFHC, 752, 753, 956
- corrugated-diaphragm vacuum gauge, 567
- cosine distribution, 132, 138, 139
- Couette flow
  - cylindrical, 189
  - plane, 186
  - shear stress, 223
  - transversal, 221
- counter flow
  - heat exchangers, 514
- counter flow leak detector
  - advantages, 681
  - detection limit, 683
  - principle, 678
  - sniffing, 936
- counterpressure, 108, 110, 111, 386, 389, 987
- covalent linkage, 229
- coverage, 233, 235, 243, 484, 488, 898
- creep barrier, 402
- Creux, Leon, 302
- critical backing pressure, 26, 272, 400, 405, 408, 455, 887
- critical point, 77, 99, 100, 399
- crossover value, 547, 552
- crossover value, 552
- cross section
  - annular, 129
  - annular slot, 129
  - rectangular, 128, 129, 199
- cryo-condensation pump, 721, 722
- cryopumps, 525, 531
  - application, 555
  - applications, 541, 542, 553
  - bath, 541, 542
  - capacity, 523
  - crossover value, 552
  - evaporator, 896
  - liquid, 558
  - pumping speed, 549, 967
  - refrigerator, 518
  - regeneration, 552
  - service life, 550
  - starting pressure, 547
  - ultimate pressure, 547, 548

- cryosorption, 525, 526, 529, 539
- cryostats, 519
  - bath, 520
  - cryotechnology, 23, 161, 512
  - cryotrapping, 525, 530
  - cycle time, 539, 922, 940
  - evaporator, 519
  - glass, 520
  - metal, 520
  - refrigerator, 518
- cryotechnology, 511
- cryotrapping, 525, 530
  
- d**
- Dalton, 37
- Dalton's law, 278
- Dalton's law of partial pressures, 37
- Davies, Isaiah, 319
- Dayton, 241
- DC motor, 267
- dead center, 262
  - top, 262
- dead space, 260, 262, 265, 298
- dead time, 667, 928
- dead volume, 315
- deflection angle, 113
- degassing, 232, 403, 619
- degree of freedom, 56, 59
- Democritus, 1, 2
- design vacuum vessels, 809
- density, 30, 34
- density ratio, 107
- desorption
  - electron-stimulated, 619, 621, 631
  - water vapor, 774
- desorption energy, 233, 234
- desorption flux density, 236
- desorption kinetics, 234
- desorption rate, 235
- detection limit, 912
- deterministic method of calculation, of gas
  - flows, 178–181
- Dewar, 520
- DeviceNet, 846
- dew point temperature, 361
- Dewar, 520
- diameter
  - hydraulic, 128
- diaphragm bellows, 781
- diaphragm clamping disc, 264
- diaphragm pump, 264, 683
  - design principles, 264–265
  - pumping speed, 265–266
  - speed control, 267
  - ultimate pressure, 267
- diaphragm vacuum gauge, 567
  - piezoresistive principle, 574
- diffuse scattering, 176, 185
- diffuse-specular model of gas-surface
  - interaction, 175
- diffusion, 39, 63, 233, 241, 247, 250, 332, 384,
  - 399, 408, 410
- diffusion coefficient, 63
  - plastic, 774
- diffusion ejector pump, 407
- diffusion pump, 399, 404
  - compression ratio, 399, 412
  - critical backing pressure, 405, 407
  - diffusion coefficient, 398
  - fore-vacuum tolerance, 405, 407, 412
  - fractionating, 403
  - operating suggestions, 404
  - pump fluid, 404
  - pumping probability, 407
  - pumping speed, 407, 408, 411
- diffusion-pump oil, 332
- dimensionless flow rate, 222
- dimensionless pumping speed, 222
- DIN standards, Table A.22
- diode pump, 501
  - differential, 500
- dipole forces, 229
- dipole moment, electrical, 69
- direct contact condenser, 372, 393, 395
- direct flow helium leak detector
  - detection system, 680
- direct flow leak detector
  - advantages, 680
  - detection limit, 680
  - principle, 681
  - response time, 682
  - sensitivity, 684
- direct simulation Monte Carlo (DSMC)
  - method. *See* probabilistic methods of
  - calculation of gas flows, 178
- discharge
  - barometric, 374
- discrete velocity method. *See* deterministic
  - method of calculation of gas flows
- dished vessel head, 807
- dissociation, 619
- distillation, 395
- distribution function of velocity, 168–169
- double-focus, 676
- drag
  - residual, 585, 588

- draining
  - barometrical, 394
- drive concepts, 267
- drying, 378
- duroplastic, 760
- dust filter, 355
- dynamic seals, 814
- dynamic viscosity, 53
- dynode, 666, 667
  
- e**
- Edison, 9, 19
- effective pumping speed, 265
- effective speed, 43
- efficiency, volumetric, 324
- effusion, 44
  - thermal, 158, 159
- effusion rate, 159
- effusion-volumetric flow, 45
- Einstein, 16
- ejector stages, 407
- elastomer, 270, 760, 797
- elastomer-seal, 794
- electrical conductors
  - analogue, 92, 852, 853
- electrical dipole moment, 69
- electron, 12
- electron beam evaporator, 491
- electron capture detector, 925
- electron cloud, 70
- electron collision, 614
- electron multiplier
  - secondary, 666
- electron-beam welding, 784
- electropolishing, 534
- EM, SEM, 622
- embrittlement
  - hydrogen, 752
- emission
  - gas, 760, 768
- emissivity, 531, 532, 534, 552
- emitting-cathode ionization gauge
  - operating suggestions, 623
- Emmett, 245
- energy
  - conservation, 193
- energy-accommodation coefficient, 58
- engine, internal combustion, 7
- Enskog, 72
- enthalpy, 526
- enthalpy of solution, 255
- enthalpy of vaporization, 76
  - specific, 76
- entropy, 108
- envelope method, 935
- enveloping, 927
- epoxy resin, 760
- equation of state, 36, 65
- equation of state of an ideal gas, 36
- ESD (electron-stimulated desorption), 654
- etching, 672
- Eucken, 60
- evacuation
  - speed, 452
- evaporation, 80, 362
  - flux density, 548
  - getter pump, 464
- evaporation pump, 489
  - design, 491
  - getter capacity, 479
  - material, 489
  - pumping speed, 480, 498
- evaporation rate, 79
- evaporator cryopump, 896
- exhalation ratio, 251
- exhaust filter, 353
- exhaust pressure, 424
- expansion
  - continuous, 700
  - static, 700
- expansion method
  - continuous, 716
  - static, 710
  - static, additional volume, 712
  - static, calibration gas, 713
  - static, expansion ratio, 713, 714
  - static, expansion system, 712
- expansion ratio, 711
- explosion protection, 348
- extensive quantities, 33
- extractor cathode, 620
- extractor ionization gauge, 619
  
- f**
- Faraday cup, 648, 661, 665
- feedthroughs, 787
  - electrical, 787, 823, 825
  - linear, 814
  - liquid, 835
  - optical, 829
  - optical fiber, 832
  - rotary, 815
  - thermocouple, 834
- FHH isotherm, 245
- Fick's first law, 63
- Fick's second law, 247

- field, magnetic, 456
  - fieldbus, 846
  - fieldbus system, 447
  - filament material, 652
  - filmic contamination, 780
  - film test chamber, 941
  - fine-vacuum ionization gauge, 614
  - flame-ionizing detector, 925
  - flange connections, 752
  - flap valve, 270
  - Fleuss, H. A., 7
  - flooding gas, 683
  - flow
    - around corner, 111
    - choked, 100, 102, 110, 118
    - circular tube, 117
    - continuum, 84
    - critical, 98
    - duct, non-circular cross section, 128
    - effluent, 108
    - entire pressure range, 151
    - frictional-viscous, 114
    - gas-dynamic, 100
    - gas-species dependent, 499
    - inviscid viscous, 93
    - Knudsen, 84
    - laminar, 86, 115, 116, 119
    - long tube, 118
    - molecular, 85, 131, 134
    - molecular, circular tube, 117
    - molecular, long tube, 118
    - molecular, medium-sized tube, 138
    - molecular, short tube, 133
    - nozzle, 102
    - Prandtl-Meyer, 111
    - short tube, 133
    - stationary, 106
    - subsonic, 106
    - supersonic, 101
    - transitional, 84
    - tubular, 114
    - turbulent, 114, 116
    - velocity, 100, 106
    - viscous, 93
  - flow conductance, 90
  - flow divider, 721
  - flow function, 97, 98
  - flow pattern, 131
  - flow rate, 87
    - through an orifice, 219
  - flow resistance, 90
  - flow types, 84
  - flowmeter of constant pressure, 717
  - fluoroplastic, 263
  - flux rate, 87, 594
  - foaming agent, 922
  - food packaging, 941
  - force
    - frictional, 436
  - fore-vacuum pressure, 414, 441
  - fore-vacuum tolerance, 405, 407, 455
  - fouling factor, 369
  - four-stage dry-runner pump, 262
  - Fourier law, 173
  - fractionating, 403
  - Frankel-Halsey-Hill isotherm, 245
  - free path, 46
    - mean, 47, 48
  - free-molecular regime and gas flow, 178, 181, 186, 201–203, 219, 205–211
  - freezing point of water, 32
  - Fremerey, 14
  - frequency converter
    - electronic, 447
    - mechanical, 447
  - Freundlich, 243
  - Freundlich adsorption isotherm, 243
  - Freundlich isotherm, 243
  - friction coefficient, 116
  - full flow filter, 352
  - funnel, 148
  - fused joints, 786
- g**
- Gaede, 12, 288, 294, 339, 396, 408, 420
  - Gaede pump, 12
    - compression ratio, 412
    - pumping speed, 405
  - Gaede pump stage, 422
  - Gaede's formula, 433
  - Gaede's molecular pump, 422, 423
  - Galilei, Galileo, 2
  - gas
    - real, 65
  - gas ballast, 261, 266, 294
    - invention, 13
  - gas behavior, 69
  - gas discharge, 12, 625
  - gas dosing valve, 823
  - gas dynamics, 93
  - gas emission, 763, 768
  - gas flow, 83, 87–90, 96, 98, 106, 117, 151, 163, 168, 172, 174, 175, 178, 180, 189, 199, 221
  - gas flow rarefaction
    - Boltzmann equation, 170–172
    - gas-surface interaction law, 175–177

- global equilibrium, 169–170
  - heat transfer, 185–199
  - in pipes, 199–218
  - and Knudsen number, 167–168
  - local equilibrium, 170
  - macroscopic quantities, 171
  - methods of calculation, 178–181
  - model equations, 174–175
  - rarefaction parameter, 167
  - temperature jump coefficient, 184–185
  - thermal slip coefficient, 183–184
  - through orifice, 218–220
  - transport coefficients, 172
  - velocity distribution function, 168–169
  - viscous slip coefficient, 182–183
  - gas friction, 586
  - gas jet vacuum pump, 387
  - gas laws, 29, 35, 37, 63
  - gas load, 448
  - gas particle size, 54
  - gas permeability, 763
    - plastic, 767
  - gas state, 29–38
  - gas theory
    - kinetic, 29
  - gas throughput, 453
  - gas-dynamic flow, 103
  - gas-friction vacuum gauge, 566, 584
    - residual drag, 585, 591
    - rotor heating, 594
  - gas-surface interaction law, 175
  - gas-vapor mixture, 366
  - gate valve, 822
  - gauge constant, 613
  - gauge sensitivity factor, 612
    - pressure-dependency, 612
  - Gay-Lussac's law, 35
  - Geissler, 7
  - GEM, 847
  - German Calibration Service, 724
  - Geryk, 7
  - getter
    - operating mode, 481
    - types, 472
  - getter capacity, 479
  - getter pump, 463
  - Gifford-McMahon process, 516, 517
  - Gifford-McMahon refrigerator, 518
  - glass, 739, 825
    - gas permeability, 763
    - hard, 756
    - quartz, 756
    - sintered, 757
    - soft, 756
  - glass bead blasting, 782
  - glass ceramics, 758
  - global equilibrium, 169–170
  - gravitational wave detectors, 23
  - grease lubrication, 444, 462
  - ground-in connections, 895
  - growth rate
    - condensate layer, 547
- ## h
- Hagen-Poiseuille equation, 116, 917
  - halogen leak detector, 691
    - alkali ion sensor, 691
    - infrared sensors, 692
  - hard-sphere model, 39, 71
  - Hauksbee, 7, 12
  - head cover, 265
  - heat capacity, 57
    - molar, 56
    - specific, 56
  - heat capacity at constant pressure, 57
  - heat conductivity, 173, 175
  - heat exchanger, 285, 292
  - heat flow, 311, 365
  - heat flux, 58, 173, 194, 223
  - heat of adsorption, 467
  - heating collars, 838
  - heating jackets, 838
  - heating tapes, 837
  - heating tents, 838
  - heat transfer
    - coefficient, 365, 366
    - radiative, 534
  - heat transfer, through rarefied gases, 185
    - between two coaxial cylinders, 195–199
    - between two plates, 193–195
    - Couette flow, 186–193
  - heat transmission coefficient, 366, 369
  - heat transport, 59, 61
  - heat, produced, 307
  - heating wire, 599, 601
  - Helicoflex seal, 804
  - helium, 556
    - atmospheric, 680, 684
    - diffusion coefficient, 909
    - permeation leak, 687
    - reference leak, 687
    - search gas, 908
    - sensitivity of helium sector field mass spectrometer, 675
    - supercritical, 556
  - helium leak detector, 449, 675, 676, 679

- adjustment, 691
  - detection limit, 683
  - direct flow, detection system, 679
  - helium pumping speedx000B8; 682, 928
  - inlet pressure, 675
  - response time, 678
  - specifications, 925
  - time constant, 925
  - time response, 678
  - helium pumping speed, 682, 925, 928
  - helium sector field mass spectrometer, 676
  - Helmer, 620, 621
  - hemispheres, 5, 6
  - Henry adsorption isotherm, 243
  - Henry’s law, 242
  - Hertz, 12
  - high-temperature brazed joints, 24
  - high-vacuum pump stand, 882
  - history, 1–16
  - Hittorf, 12
  - Ho, 407
  - Ho factor, 407, 409
  - Hobson, 240
  - Hobson model, 238
  - Holweck pump, 221–225, 426–427
  - Holweck pump stage, 426
  - Holweck rotor, 442
  - Holweck stage, 426, 681
  - Hooke, 6
  - horror vacui, 1
  - HSMS, 847
  - Hugoniot equation, 107
  - humidity
    - relative, 80
  - Huygens, 6
  - hybrid pump, 275, 276
  - hydrogen, 911
  - hydrogen embrittlement, 752
- i*
- ice condenser, 375
  - indium, 752
  - induction period, 916
  - inert gas-vapor mixture, 367
  - infrared absorption, 685
  - infrared sensor, 692
  - inlet conductance, 431
  - inlet pressure
    - helium leak detector, 926
  - inlet valve, 342, 351
  - inspection equipment, 922
  - instability
    - long-term, 728
  - insulation, 824
  - intake flow, 86
  - Interbus, 846
  - internal combustion engine, 7
  - International Temperature Scale, 32
  - internuclear potential, 72
  - intrinsic conductance, 135
  - inversion curve, 514
  - ion current transmission, 658
  - ion detector, 657
  - ion getter pump, 493–507
    - design, 497
    - diode type, 497
    - distributed, 504
    - linear, 504
    - noble-gas stabilization, 501
    - operation, 505
    - pumping speed, 498
    - residual gas spectrum, 504
    - service life, 498
    - starting pressure, 502
    - triode type, 501
    - working principle, 493
  - ion implantation, 493
  - ion rejection, 656
  - ion source, 643, 644, 648
    - axial, 651
    - closed, 651
    - molecular beam, 649
    - open, 649
  - ion spectroscopy gauge, 621
  - ionization
    - differential, 610
  - ionization gauge, 607, 608, 610, 614, 617, 732
    - Bayard-Alpert, 616, 638
    - calibration, 732
    - cold-cathode, 608
    - crossed-field, 607, 609
    - emitting-cathode, design, 610, 613
    - emitting-cathode, measurement principle, 610
    - extractor, 620
    - fine-vacuum, 615
    - heating wire, 595
    - history, 608
    - hot-cathode, 608
    - hot-cathode, design, 613
    - Lafferty, 623
    - long-term instability, 728
    - modulator method, 619
    - orientation, 637
    - parasitic errors, 618



- pumping speed, 628
- triode, 607
- ionization vacuum gauge, 621
- isentropic behavior, 96, 97
- isentropic exponent, 57, 59, 96
- ISO standards, 698, Table A.22
- ISO 9000, 684
- isothermal flow, 210–211
- isotherms, 36
- ITER, fusion reactor, 556
- ITS-90, 32

**j**

- Jaeckel, 408
- jet
  - motive, 409
- jet pump, 386, 388, 393, 415, 416, 886
  - product vapor driven, 397
- jet pump stage, 379
- jet pumps, 383, 385
- jet vacuum pump, 378, 379, 384, 388
- joining technologies, 781, 783
- joints
  - brazed, 24, 753, 788
  - cemented, 917, 926, 934
  - flexible, 761
  - fused, 832
  - metallization, 758
  - welded, 784, 785
- Joule-Thomson effect, 514

**k**

- Kanazawa, 242
- Kelvin, 36
- Kelvin temperature, 31, 32
- KF, 800
- Kilogram, 34
- kinetic theory of gases, 29, 38, 39, 40, 44, 52, 56, 59, 64, 538
- Klein flange, 800
  - components, 801
- Klixon, 346
- Knudsen, 12, 138, 154, 584
- Knudsen approximation, 531, 580
- Knudsen flow, 84, 944
- Knudsen layer, 182, 183, 184, 185
- Knudsen minimum, 204
- Knudsen number, 85, 106, 131, 153, 154, 155, 161, 167, 170, 179, 185
- Kovar, 751, 759, 832
- Krönig, 39
- Kwong, 66

**l**

- Lafferty ionization gauge, 623
- Lambert-Beer's law, 673
- lamella pump, 290
- Langmuir, 13, 235
- Langmuir adsorption isotherm, 243
- Langmuir saturation, 245
- Laval nozzle, 108, 110, 111, 387
- laws of thermodynamics
  - fundamental, 512
- layer model, 52, 54, 59, 60
- leak
  - liquid, 917
  - liquid-tight, 917
  - localization of, 912, 920, 923
  - mass spectrum, 923, 924
  - permeation leak, 687, 688, 736, 916
  - pore-like, 914, 917
  - surface tension of liquids, 917
  - types, 913
  - virtual, 917
- leak detection, 458, 655, 683, 907, 908, 911, 912, 919, 923, 926, 933, 936
  - series components, 937
- leak detection method, 918
  - bombing, 940
  - envelope method, 926
  - requirements for inspection engineers, 918
  - series production, 922
  - sniffing method, 910, 925
  - testing, integral, 920
- leak detector, 675
  - counterflow, advantages, 681
  - counterflow, detection limit, 683
  - counterflow, detection system, 682
  - counterflow, principle, 681
  - counterflow, response time, 679
  - counterflow, roughing pump, 679
  - counterflow, sensitivity, 679
  - counterflow, sniffing, 684
  - direct flow, advantages, 680
  - direct flow, principle, 679
  - direct flow, response time, 680
  - direct flow, sensitivity, 679
  - dry, 683
  - refrigerant, 685
- leak localization, 911
- leak rate
  - concentration correction, 927
  - conversion, 913
  - conversion factors, 913
  - mass flow, 913
  - pressure correction, 927

- standardized, 927
  - units, 913
  - leak rate limit, 917, 937
  - Lennard-Jones potential, 71
  - Leucippus, 1
  - linearity, 690
  - linearized collision operator, 172
  - linearized kinetic equation, 183, 186
  - liquefier, 512
  - liquid jet vacuum pump, 384, 385
    - applications, 386
    - suction pressure, 387
  - liquid manometer, 701
  - liquid ring pump, 276
  - liquid ring vacuum pump, 276
    - designs, 277
    - pumping speed, 278
    - working fluid, 278, 282
  - liquid-tight, 918
  - local equilibrium, 170
  - long-term instability, 728
  - long-term stability, 571, 577, 593, 724, 731
  - Loschmidt constant, 36
  - Louthan, 255
  - low temperatures
    - measurement of, 520
  - lubricant, 779
- m**
- Mach angle, 108, 111, 988
  - Mach line, 111, 112
  - Mach number, 100, 179, 381
  - Macor, 753, 758
  - macro-characteristics, of gas flow, 168–169
  - macroscopic properties, 38, 39, 44, 50
  - Magdeburg hemispheres, 5
  - magnetic field, 456
  - magnetic sector analyzers, 661
  - magnetron, 630
    - inverted, 630
  - main rotor, 315
  - maintenance, 455
  - manipulator, 817
  - Mariotte, 35
  - mass, 33
    - conservation, 93
  - mass analyzer, 643, 655
  - mass density, 34, 108
  - mass flow rate, 87, 181, 199, 210, 212
  - mass flowmeter
    - thermal, 604
  - mass flux rate, 913
  - mass spectra of refrigerants, 686
  - mass spectrometer
    - double-focusing, 677
    - software, 670
  - mass spectrometry, 643
  - mass spectrum
    - artifacts, 654
  - materials, 749, 752, 757, 760, 763, 768, 770, 773
    - ceramic, 757
    - gas emission, 768
    - plastic, 765
    - requirements on, 752
  - Maxwell, 9, 42, 47, 53, 60
  - Maxwell distribution function, of velocity, 170, 182
  - Maxwell-Boltzmann velocity distribution, 41, 42, 44
  - MBIS (molecular beam ion source), 649, 652
  - McLeod, 9, 15, 704
  - McMillan-Teller isotherm, 245
  - MCP, 669
  - mechanical feedthroughs, 813
  - mean free path, 45, 47
  - mean free path expression, 167
  - mean molar mass, 37
  - mean residence time, 236, 239
  - mean time between collisions, 49
  - measuring uncertainty, 465, 592
  - membrane vacuum gauge, 571, 572, 574
  - MEMS, 660
  - mercury, 400
    - density, 703
  - mercury diffusion pump, 13, 401
  - mercury U-tube, 704
  - metal cryostat, 520
  - metallization, 23, 751, 758
  - metals, 749
    - gas permeability, 764
    - saturation vapor pressure, 769
  - methane, 912, 925
  - method of calculation, of gas flows, 178–181
  - micro-plasma welding, 784
  - microchannel plate detector, 669
  - microelectronics industry, 22
  - mixtures of different gas species, 37
  - modulator, 619
  - modulator method, 619
  - molar flow rate, 87
  - molar flux rate, 87
  - molar gas constant, 36
  - molar mass, 35
  - molar volume under standard conditions, 36
  - mole, 35
  - molecular beam method, 722

- molecular flow, 131
- molecular sieve, 467, 526
- molecular speed, 167, 169, 170
- molecule, 34
- momentum, 40, 51, 183
  - conservation, 106
- monitoring, 843
- monolayer adsorption isotherms, 242
- monolayer formation time, 246
- monolayer time, 246, 485
- monomolecular layer, 232
- Monte Carlo simulation, 138, 143, 719
- Moore, 252, 253
- most probable speed, 43, 188, 199
- motive fluid, 383, 384
- motive jet, 409, 415
- motive steam, 379, 387
- motive-steam consumption, 393
- motor
  - AC, 267
  - three-phase, 267
  - brushless direct current, 447
  - DC, 267
  - brushless, 267
  - three-phase asynchronous, 447
- motor switch, protective, 346
- MSLD, 684
- MT isotherm, 245
- Mu-metal, 753
- multilayer adsorption, 244
- multiple vane pump, 290, 862
- multistage pump, 260, 317, 330
  
- n**
- Navier-Stokes equation, 178, 187, 190, 202
- NEG
  - material, 467
- NEG pump, 474
  - activation, 474
  - applications, 481
  - design, 478
  - getter capacity, 479
  - operating recommendations, 481, 482
  - pumping speed, 479
  - reactivation, 481
  - ventilation, 482
- neutral particle implantation, 494
- Newcomen, Thomas, 10
- Newton, 53
- Newton's approach, 116
- NIST, 700
- nitrogen liquefying, 514
  
- noble gases, 12, 56,60
- noble-gas instability, 500
- noble-gas stabilization, 501
- non time counter (NTC) method, 180
- non-diffuse scattering kernel, 185
- non-isothermal flows, 211–212
- non-linearity, 690
- nonmetals
  - saturation vapor pressure, 770
- Northey type, 313
- Nottingham, 14, 609
- nozzle cap vapor trap, 403
- nozzle flow, 102
- number density, 168, 171
  - of molecules, 34
  - of particles, 36
  
- o**
- Oatley's approach, 147
- occlusion, 232
- OFHC copper, 752
- oil, 762
- oil backflow, 336
- oil blow, 290
- oil blow-out, 298
- oil cleaning, 352
- oil diffusion pump, 401, 405
- oil filter, 291, 293, 352
- oil level, 348
- oil lubrication, 444, 445
- oil reservoir, 291
- oil-mist separator, 291, 292, 353
- oil-vapor backflow, 336, 455
- OIS (open ion source), 649, 659
- once-through lubrication, 292, 348
- operating technique
  - fine-vacuum, 870
  - high-vacuum, 879
  - low-vacuum, 860
  - ultrahigh-vacuum, 892
- operation, valveless, 884
- orbitron pump, 464, 507
- O-rings, 799
- oscillating positive displacement pump, 260, 262
- oscillating pumps, 259
- oscillating rotating displacer, 260
- outgassing, 247
  - ratio, 251
- overlap ratio, 432
- overpressure leak detection, 683, 908
  - with helium leak detector, 683, 908
- ozalid paper, 925

**P**

- parallel connection, 91, 266
- partial flow factor, 930, 931, 932
- partial flow operation, 925, 929, 930
- partial pressure, 645
  - analysis, 643
  - minimum detectable, 645, 646, 648
- partial pressure gauge, 645
  - contribution to neighboring mass, 633
  - ion source, 669
  - resolving power, 645
  - sensitivity, 645
- partial pressure measurement
  - optical methods, 672
- partial pressure sensitivity, 644, 676
- particles, 29, 779
  - diameter, 46, 48, 55
  - flow, 44, 131
  - flow rate, 87, 247
  - mass, relative, 35, 67
  - number, 33
  - properties, 69
- Pascal, Blaise, 3, 30
- Penning, 14, 609
  - cell, 493, 495, 497, 628
  - discharge, 493, 496, 498, 625
  - gauges, 625
- Périer, Florin, 3
- permanent connections, 783
- permeability, 762
  - glass, ceramics, 764
  - metals, 764
- permeation, 254
- permeation leak, 687, 688
- permeation rate, 255
- Petit, Pierre, 3
- Physikalisch-Technische Bundesanstalt, 15, 700, 704
- physisorption, 229, 463
- piggyback design, 292
- pipes, gas flow through
  - as function of pressures and temperatures, 208–209
  - definitions, 221
  - free-molecular regime, 201–202, 684
  - of variable cross section, 214–216
  - slip flow regime, 202–203
  - under thermo-molecular pressure ratio (TPR), 216–218
- Pirani, 14, 594
- Pirani vacuum gauge, 62, 594
- piston gauge, 707
  - effective area, 707
- piston pump, 262
  - reciprocating, 262
- Plücker, 12
- plastic, 760
  - diffusion coefficient, 771
  - duroplastic, 760
  - elastomers, 760
  - gas permeability, 767
  - thermoplastic, 760
- plate baffle, 402
- plenists, 4
- plug-type connector, 833
- Pneurop, 260, 295
- Pneurop guidelines, 260
- Poiseuille coefficient, 201–204, 206–208, 210, 224
- Poiseuille flow, transversal, 221
- Poisson's equations, 96
- positive displacement pump, 259–262, 264, 265, 276, 288, 302, 305, 313, 328, 331, 332, 345, 866
  - operating recommendations, 347
  - operating temperature, 345
  - power requirements, 341
  - technical safety recommendations, 348
- positive displacement pump, oil-sealed
  - oil backflow, 336
  - pumping speed, 329
  - ultimate partial pressure, 329, 332
  - ultimate pressure, 329, 332
- power
  - frictional, 437, 439
  - specific, 316
  - thermal, 439
- Prandtl number, 174
- Prandtl-Meyer flow, 111
- Prandtl-Meyer procedure, 111
- pressure, 29
  - absolute, 29
  - critical, 100, 111, 118
  - differential measurement, 575
  - inherent, 65
  - inner, 65
  - standard, 30
- pressure balance, 699, 707, 709
- pressure controller, 582
- pressure difference, 567
- pressure loss measurement, 920
- pressure measurement, 871
- pressure measuring transducer, 593
- pressure regulation, 822
- pressure rise measurement, 920
- pressure scaling, 701

- pressure switch, 582
  - pressure testing, 919
  - pressure, ultimate, 332, 468, 854, 897
  - primary standard, 565, 699
  - Prince Rupprecht, 13
  - probabilistic method of calculation, of gas flows, 179, 181
  - probability of condensation, 79
  - process
    - chemical, 395
  - process control
    - advanced, 845
    - AEC, 849
    - APC, 845, 849
    - FDC, 850
    - PCA, 850
    - SPC, 845, 849
  - process gas, 439, 649
  - process gas flow, 855
  - process monitoring, 843, 844, 845
  - process parameter
    - monitoring, 849
  - process sensor, 843, 849
  - process-data analysis, 848, 849, 850
  - production control, 845
  - Profibus, 845
  - profile head aperture, 309
  - Profinet, 847
  - pulse counting mode, 666
  - pulse tube cooler, 518
  - pump, 5
    - chemical, 264
    - compound, 422
    - corrosive-gas, 448
    - diffusion ejector, 407
    - hybrid, 407
    - molecular, 419, 420, 422
    - split-flow, 449
  - pump combination, 317
  - pump fluid, 400
  - pump inlet, 91
  - pump oil
    - fluorinated, 425
  - pump stage
    - turbomolecular, 430
  - pump stand
    - fine-vacuum, 873, 877
    - high-vacuum, 882
    - low-vacuum, 862
  - pump unit, 280, 294
  - pump-down curve, 238
  - pump-down time, 272, 274, 452
  - pumping capacity, 266
    - critical, 104, 105
    - effective, 326
  - pumping probability, 409, 411, 431
  - pumping speed, 89, 90, 222, 265, 275, 549
    - effective, 92
    - influence of gas species, 269
    - net, 92
  - pumping speed measurement, 332, 740–742
  - pumps
    - dry, 22
  - pure-oxide ceramics, 757
  - purge gas, 448, 457, 458
  - Puy de Dôme, 3
  - p-V-diagram, 36, 342
  - pV flow, 87, 484
- q**
- QCF flange, 801
  - QMS (quadrupole mass spectrometer), 655, 659
  - quadrupole mass analyzer, 655
  - quadrupole mass filter, 649
    - stability region, 656
  - quadrupole mass spectrometer, 649, 733, 734, 736, 923, 932
    - miniaturized, 659
    - transmission, 658
  - quality standard ISO 9001, 925
  - quartz Bourdon tube vacuum gauge, 570
  - quartz glass, 756
    - diaphragm, 687
- r**
- R134a, 686
  - R22, 686
  - R600, 686
  - R600a, 686
  - Röntgen, 12
  - radiation, 436
    - flow, 532
    - flux, 532
    - shield, 534
    - thermal power, 531
  - railways
    - atmospheric, 10
    - vacuum, 10
  - Ramsay, 12
  - rarefaction parameter, 167, 188, 189, 191, 192
  - Raschig ring, 356
  - rate of flow, 87
  - rate of incidence, 44
  - rate of recombination, 252
  - Rayleigh, 12

- real gases, 65
  - reciprocating piston pump, 262
  - recombination, 252
  - recombination rate, 252
  - recuperators, 514, 515
  - Redhead, 241
  - Redlich, 66
  - reduced collision integral, 73
  - reduced flow rate, 209, 214, 219, 225
  - reduced temperature, 73
  - reduced virial coefficient, 73
  - reference leak, 687
    - calibration, 689
    - helium, 689
    - temperature coefficient, 689
  - reflector electrode, 620
  - refrigerant, 685, 687
  - refrigerant leak detector, 685
  - refrigerant loss, 936
  - refrigerating power, 515
  - refrigerating system, 936
  - refrigerating technology, 511–513
  - refrigerator, 516, 517, 687
    - Gifford-McMahon, 516
  - refrigerator cryopump, 518, 543
  - refrigerator cryostat, 519
  - refrigerators/air conditioners, 925
  - regeneration, 552
  - Regnault, 65
  - relative atomic mass, 35
  - relative humidity, 80
  - relative particle mass, 35
  - remote control, 447
  - replenishment equipment, 546
  - residence time, 236
  - residual drag, 588
  - residual gas analyzer, 643, 733
    - calibration, 736
  - resistance, 90, 147
  - resistance evaporator, 491
  - resolving power, 645
  - response time, 678, 682, 691, 929
  - reversible process, 513
  - Reynolds number, 87, 115, 117
  - RGA (residual gas analyzer), 646
  - Right-angle valve, 817
  - Roots blower, 319
  - Roots pump, 275, 295, 317
    - basics, theoretical, 322
    - compression ratio, 319, 323
    - efficiency, volumetric, 324
    - gas flow, effective, 322
    - installation, 331
    - operating principle, 305
    - operating suggestions, 331
    - technical setup, 320
  - Roots, Francis M., 319
  - Roots, Philander H., 319
  - rotary plunger pump
    - stages, 298
  - rotary-current asynchronous motor, 319
  - rotating displacer
    - single-spool, 260
    - twin-spool, 260
  - rotating plunger pump, 260
  - rotating positive displacement pump
    - dry compression, 313
    - liquid sealed, 259
    - lubricant-free, 261
    - single-shaft, 276
    - twin-spool, 305
  - rotation, 56
  - rotor, 441–442
  - rotor disc, 420
  - rotor fracture, 443, 455
  - rotor temperature, 448, 455
- S**
- safety bearing, 426, 445, 446, 447, 457
  - safety valve, 351–352, 861, 885
  - sapphire, 758
  - saturation flow rate, 376
  - saturation pressure, 523
  - saturation ratio, 80, 951
  - saturation temperature, 361, 362, 365
  - saturation vapor pressure, 75–79, 245, 339
    - metals, 769
    - nonmetals, 770
  - Sawada, 302
  - sccm, 605, 913
  - Schott, 6
  - screw type pump, 305
    - pumping speed, 294–296, 862
    - tooth profile, 305–309
  - scroll pump, 260, 302–305, 684
  - sealing faces, 575
  - sealing force, 752, 800–803
  - sealing gap, 307, 308, 312–315, 319
  - sealing with foil, 927
  - seals, 777–839
  - search gas, 908
    - helium, 679, 908
  - search gas method, 908
  - search gas species, 908
  - secondary electron multiplier, 665, 666
  - secondary standard, 699, 700, 717

- SECS, 847, 848
- self-diffusion, 64, 72
- SEM, 622, 623, 648, 666–667
- SEMI, 847
- semiconductor industry, 261, 319, 605, 683, 685, 847, 848, 892
- sensitivity, 611, 613, 617, 618, 731–736
- sensitivity drift, 690
- sensor
  - integration, 845, 847, 848
- series connection, 91–93, 145
  - components, 146
  - tube and aperture, 145
- shear stress, 168, 169, 188
- shear viscosity, 167, 172
- shell baffle, 402
- shielding
  - magnetic, 750, 753
- shock, 106
  - compression, 103
  - perpendicular, 106
  - straight, 105
- shock surface, 95
- Siegbahn, 427
- Siegbahn pump stage, 427
- Siegbahn’s molecular pump, 427
- sieve
  - molecular, 526
- Sievert’s law, 475
- silicate ceramics, 757
- silicone oil, 332
- sliding valve, 901
- sliding vane rotary pump, 292, 293
  - dry, 293
  - oil-lubricated, 292
  - once-through lubricated, 292
  - operating behavior, 276
  - operating principle, 260
- S model equation, for rarefied gas flow, 175
- Smoluchowski, M., 138
- sniffing device, 683
- sniffing leak detection
  - integral, 919, 920
  - leak localization, 936
  - on refrigerators/air conditioners, 936
  - sniffing velocity, 936
- sniffing method
  - measurement results, 910
  - search gas distribution in front of a leak, 909
- soldering, 783, 786
- solders
  - hard, 789
  - material, 787
- solid condensation, 375
- solubility, 255
- solution enthalpy, 255
- sorption, 229
- sorption medium, 350
- sorption phenomena, 229
- sorption pump, 463, 464
- sorption trap, 337, 350
- space charge, 618
- space simulation, 23
- specific enthalpy of vaporization, 76
- specific gas constant, 36
- speed
  - circumferential, 423
  - control, 264, 268, 287, 312
  - effective, 43
  - most probable, 42
  - of sound, 41
- spinning rotor gauge, 584, 585, 728, 729
  - calibration, 728
  - long-term instability, 728
- split-flow pump, 449
- Sprengel, 7
- sputter ion pump, 233, 463
  - noble-gas instability, 500
- stability
  - long-term, 700, 724
- standard
  - primary, 698
  - primary, comparison, 697, 698
  - secondary, 697, 699
- standard condition, 33
- standard pressure, 30
- standard temperature, 33
- StarCell® triode pump, 502
- starting time, 916
- state variables, 29, 33
- static pressure ratio, 108
- stationary flow, 700
- stator disc, 420
- steam jet vacuum pump, 378, 384, 387
  - multistage, 393
- steel
  - mild, 749
  - special alloys, 751
  - stainless, 750
- Stefan-Boltzmann law, 438, 532
- sticking probability, 539
- Stirling process, 515
- straight-way valve, 375
- stress
  - mechanical, 436
- sublimation, 75

- sublimation getter pump, 464
  - sublimation pump, 463
  - suction chamber, 260, 261
  - sulfur hexafluoride, 912, 925
  - superheat, 332, 362
  - suppressor, 677
  - surface analysis, 23
  - surface area
    - specific, 463
  - surface condensation rate, 79
  - surface condenser, 370, 371
  - surface coverage, 233, 484
  - surface evaporation rate, 79
  - surface-adsorption rate, 242
  - surface-desorption rate, 236
  - Sutherland, 13, 48
  - Sutherland's constant, 48, 49
  - Swagelok, 801, 805
    - connector, 801
  - system control, 845
  - system leak detection, 931
    - response time, 931
    - sensitivity, 931
    - throttle valve, 931
  - system, ultrahigh-vacuum, 898
- t**
- TDC (top dead center), 262
  - tangential velocity, 52, 183, 586
  - tangential-momentum accommodation
    - coefficient, 51, 586
  - tantalum, 79, 477
  - TCP/IP, 846, 847
  - Teller, 244
  - Temkin isotherm, 243
  - temperature, 31
    - standard, 33
  - temperature coefficient, 601, 605, 688
  - temperature correction, 721, 731
  - temperature difference, 58, 158, 839
    - mean, 365
  - temperature jump coefficient, 184–185
  - temperature of condensation, 368
  - temperature of dew point, 361, 362, 365
  - temperature scale
    - thermodynamic, 32
  - test equipment (leak detection), 689
  - test leak, 735–738, 934
    - calibration, 735–738
  - testing chamber method, 927
  - thermal conduction, 535
    - integrals, 536
  - thermal conduction flux, 532
  - thermal conductivity, 39, 48, 55–62, 537, 538, 594–597
  - thermal conductivity coefficient, of gas
    - flow 173
  - thermal conductivity vacuum gauge
    - cleaning, 871
    - constant heating, 601, 602
    - constant wire temperature, 597–601
    - operating guidelines, 893–897
  - thermal creep coefficient, 201–203, 206, 208, 224
  - thermal radiation, 531
  - thermal slip coefficient, 183, 184
  - thermal transpiration, 580–582, 636, 726
  - thermistors, 603
  - thermometer, 522
  - thermo-molecular pressure ratio (TPR), 216–218
  - thermocouple vacuum gauge, 602–603
  - thermodynamic temperature, 31, 32, 36, 130, 135
  - thermodynamics
    - fundamental laws, 513
  - thermoplastic, 271, 760, 761
  - Thomson, J., 12, 514
  - throughput, 87, 89, 453–455
  - TIG welding, 784
  - tightness
    - absolute, 835, 887, 917
  - tightness testing
    - industrial, 691, 692, 919, 922, 934, 937
    - standards, 919
    - terms, 919
  - tightness testing system, 938
  - time constant, 866, 928
  - titanium, 492, 751
  - titanium evaporation pump, 489–490, 492, 894
  - tooth profile, 305–309
  - tooth type pump
    - twin-spool, 305
  - tooth type rotary pump, 260, 314, 316, 318
  - top dead center, 262, 297
  - Torricelli, Evangelista, 2–4
  - Torricellian tubes, 3, 5
  - Torricelli's vacuum experiment, 3
  - transducer
    - pressure measuring, 593, 594
  - transmission probability, 131, 132, 135, 138–149, 430, 539, 540, 545
  - transpiration
    - optical, 831
    - probability, 539
    - thermal, 159, 580, 636, 726, 729, 731



- transport coefficients, of gas flow
  - Prandtl number, 174
  - thermal conductivity coefficient, 173–174
  - viscosity coefficient, 172–174
- transport of frictional forces in gases, 51–55
- transport properties of gases, 50–51
- triode pump, 501–504
  - concentric, 614
- triple point, 32, 375, 396
- trochoidal pump, 300–302
- tube
  - conical, 148–150
  - constant cross-sectional area, 137, 138
  - long, circular cross section, 139
  - simple cross section, 140–143
- tube bend, 143–145
- tube bundle condenser, 370, 371
- tube elbow, 143–145
- tungsten inert-gas welding, 784
- turbine condenser, 368
- turbomolecular pump, 419, 420, 422, 889, 890
  - applications, 429
  - base pressure, 450
  - bearing arrangement, 443
  - characteristics, 450
  - compression ratio, 448, 450
  - design, 440
  - operating principle, 422
  - operation, 426
  - pumping mechanism, 430
  - pumping speed, 431
  - safety requirements, 442
  - thermal balance, 436
  - ultimate pressure, 451
  - venting, 456
- u**
- U-tube manometer, 565
- UHV system, 893
- ultimate pressure, 262–270, 273–276, 284, 289–291, 294–296, 298, 300, 303, 304, 315, 317, 324, 329–333, 334–337, 340, 347, 348, 353, 386, 399, 403, 415, 450, 451, 455, 469–471, 473, 481, 498, 525, 542, 548–550, 683, 763, 778, 783, 852, 854, 855, 865, 866, 875, 876, 894, 985–992
  - influence of gas species, 269
  - influence of rotational speed, 269
- ultraclean vacuum (UCV), 781
- ultrahigh-vacuum system, 892
- undercooling, 368, 373
- v**
- vacuists, 4
- vacuum
  - absolute, 16
  - definition, 1, 23, 25
  - measurement, 13
  - railways, 10
  - relative, 30
- vacuum annealing, 855
- vacuum chamber method, 938
- vacuum components, 777, 791, 938
  - cleaning, 871
- vacuum drying system, 377
- vacuum gauges, 760
  - Bourdon tube, 566, 568
  - capacitance, 576
  - capsule element, 566, 568
  - corrugated-diaphragm, 567
  - diaphragm, 567
  - gas-friction, 566, 584
  - ion spectroscopy, 621
  - mechanical, 566
  - membrane, 571
  - piezoelectric, 575
  - quartz Bourdon tube, 570
  - spinning rotor, 584
  - thermal conductivity, 594
  - thermocouple, 602
- vacuum hygiene, 778
- vacuum leak detection, 675, 907, 923
- vacuum process chamber, 843, 844
- vacuum process technology, 420, 453
- vacuum pumps, 5, 19, 23, 353
  - characteristics, 450
  - ultimate pressure, 851
- vacuum ranges, 23
- vacuum system, 835, 843
  - connecting points for leak detectors, 931
  - longest, 23
  - process, 843
  - ultimate pressure, 851
- vacuum technology
  - applications, 19–26
  - components, 708, 715, 718, 747, 749, 750–753, 758, 777, 806–810
  - scope, 19–26
  - seals, 768, 794–796, 798, 799, 800, 802, 804, 814, 818, 832, 855, 861, 871, 886, 893, 914, 917, 926
- vacuum vessel, 809
  - design, 809
  - dimensioning, 811
- valves, 817

- butterfly, 859
  - corner, 892
  - electromagnetic, 822
  - flap, 270
  - gas dosing, 580
  - pneumatic, 821
  - right-angle, 817
  - sealing, 270, 752
  - sliding, 901
  - straight-way, 375
  - valveless operation, 884
  - van der Waals, 66
    - equation of state, 66
  - van der Waals forces, 229
  - vane, 287
  - vane wear, 293
  - vapor, 75
    - saturated, 79, 367
    - superheated, 332, 362, 363
  - vapor jet pump
    - pumping speed, 416
  - vapor jet vacuum pump, 379
    - motive-steam consumption, 391
  - vapor pressure, 245, 278, 524
  - vapor pressure curve, 361, 362, 367, 377
  - vapor trap, 401
    - nozzle cap, 401
  - VATSEAL, 803
  - VCR connector, 5, 805
  - velocity
    - acoustic, 99
    - critical, 101, 103
  - velocity distribution function, of gas flow, 168–169
    - for channel, 200
    - for Couette flow, 185–192, 194, 198, 221, 223
    - for cylindrical variables, 190–191
    - for Poiseuille flows, 204
    - for thermal creeps, 205
    - for tube, 202
    - for wide channels, 202
    - in free-molecular regime, 201–202
    - in slip flow regime, 202–203
    - in transitional regime, 303–308
    - of BGK model, 175, 178, 183
    - of S model, 183, 185, 195, 197–198
  - velocity gradient, 172
  - velocity ratio, 424, 431, 432, 433
  - vena contracta, 102
  - vent valve, 440
  - venting, 456–457, 603, 619, 770, 821, 851
  - vessel, 5
    - double-walled, 809–810
  - vessel head
    - dished, 807, 810
  - vibration, 56
  - viewports, 829
  - virial coefficient, 66
  - virial coefficient, reduced, 73
  - virtual leaks, 778
  - virial series, 66
  - viscosity, 39, 48
    - dynamic, 53
  - viscosity coefficient, of gas flow, 172–173
  - viscous slip coefficient, 182–183
  - viscous state, 51
  - volume, 33
    - inherent, 65
    - molar volume under standard conditions, 36
  - volume charge, 494–495, 626
  - volume collision rate, 49
  - volume flow rate, 87
  - volume flux rate, 87
  - von Baeyer, 14
  - von Guericke, Otto, 4
    - air pump, 5
    - painting showing experiment, 6
    - vacuum technique, 5
- w**
- wall flux density, 170
  - wall pressure due to impacting particles, 39
  - wall thickness, 784–785, 811–813, 917
  - water
    - freezing point, 32
    - triple point, 32
  - water jet pump, 385–387
  - water pump, 5
  - water ring pump, 276
  - water testing, pressurized, 918
  - water tightness, 918, 922
  - water vapor capacity, 331
  - water vapor desorption, 678, 917
  - water vapor tolerance, 339, 341, 381
  - weld seam, 786, 935
  - welded joints, 784, 785
  - welding, 784
    - electron beam, 784
    - explosion, 784
    - friction, 784
    - laser beam, 784
    - micro plasma, 784
    - TIG, 784
    - tungsten inert-gas, 784

Wheatstone bridge, 594, 598, 599, 601  
Wheeler flange, 939  
window, 756  
working pressure, 851, 854, 855

**x**

xenon, 524  
X-ray effect, 609

– inverse, 618  
X-ray limit, 623, 631  
X-rays, 12

**z**

zeolite, 467, 471, 758  
zero-point compensation, 598  
zero-point drift, 670















